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WHAT IS CLAIMED IS:

1	1.	An apparatus comprising:
2		a substrate; and
3		a carbon nanotube layer deposited on the substrate, the carbon nanotube layer
4	inclu	ding an alkali material.

- 2. The apparatus as recited in claim 1, wherein the alkali material is deposited as a layer onto the carbon nanotube layer.
- 3. The apparatus as recited in claim 1, wherein the alkali material is doped into the carbon nanotube layer.
- 4. The apparatus as recited in claim 1, wherein the alkali material is intercalated with the carbon nanotube layer.

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1	Э.	An apparatus	comprising:
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- 2 a substrate; and
- a carbon nanotube layer deposited on the substrate, the carbon nanotube layer including a separate low work function material.
- 1 6. The apparatus as recited in claim 1, wherein the low work function material is deposited as a layer onto the carbon nanotube layer.
 - 7. The apparatus as recited in claim 1, wherein the low work function material is doped into the carbon nanotube layer.
 - 8. The apparatus as recited in claim 1, wherein the low work function material is intercalated with the carbon nanotube layer.
 - 9. The apparatus as recited in claim 1, wherein the low work function material is an alkali material.

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1	10.	A field emission apparatus comprising:		
2		a cathode comprising:		
3		a substrate; and		
4		a carbon nanotube layer deposited on the substrate, the carbon nanotube layer		
5	including an alkali material.			
1	11.	The apparatus as recited in claim 10, wherein the alkali material is deposited as a		
2	layer o	layer onto the carbon nanotube layer.		
1	12.	The apparatus as recited in claim 10, wherein the alkali material is doped into the		
2	carbon	carbon nanotube layer.		
1	13.	The apparatus as recited in claim 10, wherein the alkali material is intercalated with		
2	the car	e carbon nanotube layer.		
1	14.	The apparatus as recited in claim 10, further comprising a conductive layer deposited		

between the substrate and the carbon nanotube layer.

1	15.	A method for making a field emission cathode comprising the steps of:	
2		providing a substrate;	
3		depositing a carbon nanotube layer on the substrate; and	
4		inserting an alkali material into the carbon nanotube layer.	
1	16.	The method as recited in claim 15, wherein the inserting step further comprises the	
2	step of		
3		depositing a layer of the alkali material on the carbon nanotube layer.	
1	17.	The method as recited in claim 15, wherein the inserting step further comprises the	
2	step of		
3		doping the carbon nanotube layer with the alkali material.	
1	18.	The method as recited in claim 15, wherein the inserting step further comprises the	
2	step of	:	
3		intercalating the alkali material into the carbon nanotube layer.	